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Signature

Date of Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## For: Tunneling Magnetoresistive Element And Method Of Manufacturing The Same

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) Examiner: Paul Kim  
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) Group Art Unit No.: 3729  
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**Mail Stop AMENDMENT**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

**Remarks** begin on page 9 of this paper.